

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:)	CONFIRMATION NO.: 1005
)	
Yasuo KOBAYASHI, et al.)	
)	
U.S. Serial No.: 10/568,461)	Group Art Unit: 2812
)	
Filed: February 15, 2006)	Examiner: Reema Patel
For: SEMICONDUCTOR DEVICE, MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE, AND GAS FOR PLASMA CVD PROCESS		

RESPONSE TO OFFICE ACTION DATED APRIL 10, 2009

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A reply to the Office Action of April 10, 2009 was due by July 10, 2009. Submitted herewith, together with the requisite fee, is a Petition for extending the time of reply up to and including October 10, 2009. Please accept these papers as timely filed.

Please further consider this application as follows.